

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Patent Application of:

Hacene Lahreche, et al.

Serial No. 10/516,358

Filed: November 24, 2004

For: METHOD FOR EPITAXIAL GROWTH
OF A GALLIUM NITRIDE FILM
SEPARATED FROM ITS SUBSTRATE

Examiner: Matthew J. Song

Art Unit: 1722

AMENDMENT AND RESPONSE TO OFFICE ACTION

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated January 11, 2007, Applicants submit the following amendments and remarks: